

**Notice of References Cited**

Application/Control No.

10/591,279

Applicant(s)/Patent Under

Reexamination

KOBAYASHI ET AL.

Examiner

Jeffrey Lenihan

Art Unit

1796

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**U.S. PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
A	US-			
B	US-			
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D	US-			
E	US-			
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J	US-			
K	US-			
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**FOREIGN PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
N	WO-2003029299-A1	09-2002		Kobayashi, N. et al	
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**NON-PATENT DOCUMENTS**

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